## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 89518

CHEN, Hui-Mei, et al. : Confirmation Number: 3341

Application No.: 10/786,807 : Group Art Unit: 2822

Filed: February 25, 2004 : Examiner: AU, Bac H.

For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

## TRANSMITTAL

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria VA 22313-1450

I hereby certify that this correspondence is being electronically-transmitted to the United States Patent and Trademark Office on February 2, 2011.

CERTIFICATE OF ELECTRONIC TRANSMISSION

/Nicole San Nicolas/ Nicole San Nicolas

Dear Sir:

Transmitted herewith is a Response/Amendment, including a Petition for Two-Month Extension of Time, and an Information Disclosure Statement along with 28 references in the above-identified application.

The fee has been calculated as shown below:

The fee has been calculate	d as shown below:				
	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	20	0	\$52.00 =	\$0.00
Independent Claims	3	3	0	\$220.00 =	\$0.00
Fee for extension of time				\$490.00	
		Information Disclosure Statement			\$180.00
Total of Above Calculations				ve Calculations	\$670.00

Please charge my Deposit Account No. 502624 in the amount of \$670.00.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 502624, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

/Dennis A. Duchene/ Dennis A. Duchene Registration No. 40,595

11682 El Camino Real, Suite 400 San Diego, CA 92130 Phone: 858.720.3300 DAD:GR/nsn Facsimile: 858.720.7800

Date: February 2, 2011

Please recognize our Customer No. 89518 as our correspondence address.